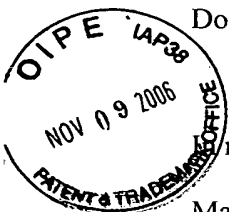


DFW



Docket No.: 060188-0730

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of

Masayuki ENDO, et al.

Application No.: 10/735,688

Filed: December 16, 2003

For: PATTERN FORMATION METHOD

: Customer Number: 20277
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: Confirmation Number: 3573
:
: Group Art Unit: 1756
:
: Examiner: SULLIVAN, CALEEN O
:

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

CERTIFICATION PARAGRAPH

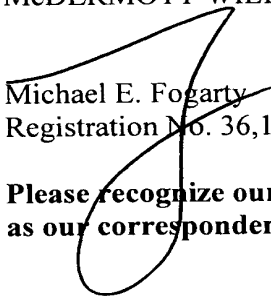
The undersigned certifies that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement as described in 37 CFR 1.97(e)(1).

The references were cited in a corresponding foreign application office action and their relevance is discussed therein. A copy of the foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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SHEET 1 OF 1

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. 060188-0730		SERIAL NO. 10/735,688	
				APPLICANT Masayuki ENDO, et al.			
				FILING DATE December 16, 2003		GROUP 1756	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document		Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		US					
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes -Number -Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document		Pages, Columns, Lines Where Relevant Figures Appear	Translation Yes No
		JP 2001-66780 A	03-16-2001	MATSUSHITA ELECTRIC IND CO LTD			JAPAN (w/English abstract)
		JP 4-321049 A	11-11-1992	TOYO GOSEI KOGYO KK			JAPAN (w/Partial English translation)
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.					
		T. A. BRUNNER. "High NA lithographic imagery at Brewster's angle". Optical Microlithography XV, Proceedings of SPIE, 2002, 1-9, Vol 4691.					
		Japanese Patent Office Notice of Reasons for Rejection, in corresponding Japanese Patent Application No. JP 2003-037917, dated September 19, 2006.					
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.